PATENT NUMBER and ISSUE DATE

U.S. UTILITY Patent Application

***CONTINUING DATA VERIFIED: ***FOREIGN APPLICATIONS VERIFIED: REPUBLIC OF KOREA 2001-11541 03/06/2001 PG-PUB DO NOT PUBLISH RESCIND Foreign priority claimed yes no ATTORNEY DOCKET NO 35 USC 119 conditions met yes no SEC.927 TITLE: Wafer support plate assembly having recessed upper pad and vacuum processing appa comprising the same	10087833	FILING DATE 03/05/2002	CLASS	SUBCLASS	GAU		XAMINER
***FOREIGN APPLICATIONS VERIFIED: REPUBLIC OF KOREA 2001-11541 03/08/2001 PG-PUB DO NOT PUBLISH RESCIND ATTORNEY DOCKET NO SUSC 119 conditions met yes no verified and Acknowledged Examiners's initials TITLE: Wafer support plate assembly having recessed upper pad and vacuum processing appar comprising the same US DEPT. OF COMM. PAT A TM. PTO-436.			204	.293.51	1741	Mil	(5
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TITLE: Wafer support plate assembly having recessed upper pad and vacuum processing appa comprising the same USIDEPT OF COMM.PAT & TM-PTO-436L	REPUBLIC OF PG-PUB DO N Foreign priority clair	KOREA 2001-11	541 03/06/ □ yes	RESCIN □ no		TTORNEY	DOCKET NO
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NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED
	Assistant Examiner	Total Claims 200 Feb. Print Claim for O.G
ISSUE FEE		DRAWING CALL
Amount Due Date Paid		Sheets Drug. Figs. Drug. Print Fig.
**************************************	Primary Examiner	
TERMINAL	PREPARED FOR ISSUE	Application Examiner
DISCLAMER	WARNING: The information disclosed Unauthorized disclosure may be prohibit Sections 122, 181 and 368, Possession o Office is restricted to authorized employ	ed by the United States Code Title 35 authors the U.S. Patent & Trademark
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